

207 347  
SUBCLASS  
ISSU CLASSIFICATION

U.S. UTILITY Patent Application

CLASS. 347  
PATENT EXAMINER

APPLICATION NO. 09/787877	CONT/PRIOR D F	CLASS 257.	SUBCLASS 347	ART UNIT 2877 2822	EXAMINER Soward
------------------------------	-------------------	---------------	-----------------	--------------------------	--------------------

APPLICANTS  
Takashi Morishita  
Masahiro Matsui

TITLE  
Semiconductor substrate and its production method, semiconductor device comprising the same and its production method

PTO-2040  
12/83